



Depletion depth studies on high thickness to pixel size ratio silicon devices

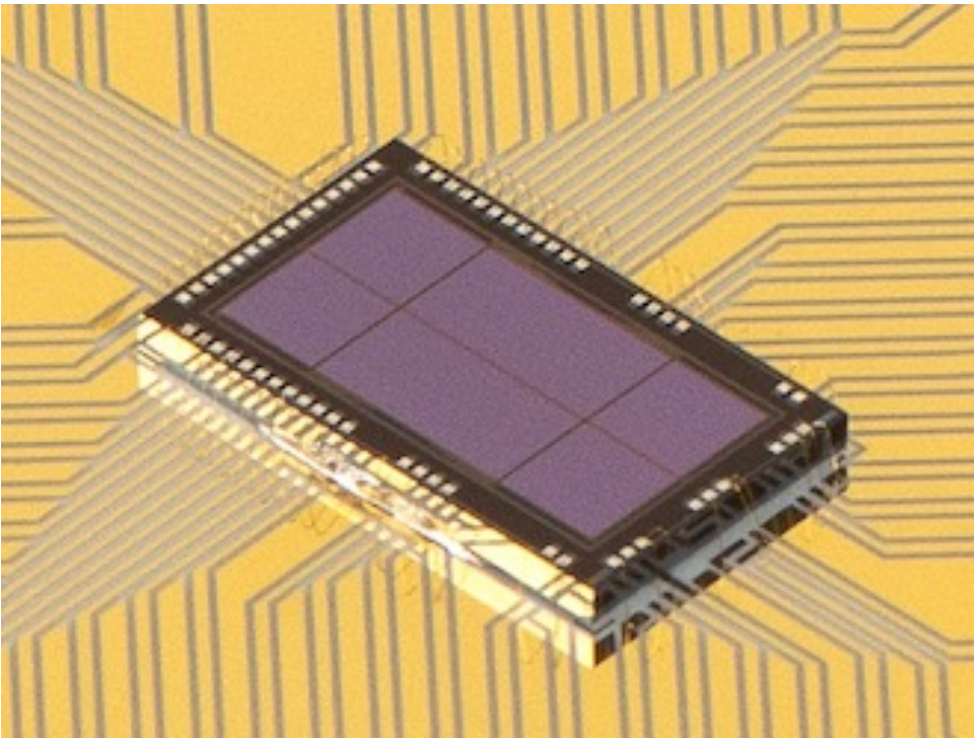
Beverly LaMarr

Sources

Measurement and simulation of charge diffusion in a small-pixel charge-coupled device, Beverly J. LaMarr , Gregory Y. Prigozhin, Eric D. Miller, Carolyn Thayer, Marshall W. Bautz, Richard Foster, Catherine E. Grant, Andrew Malonis, Barry E. Burke, Michael Cooper, Kevan Donlon, Christopher Leitz
<https://doi.org/10.1117/1.JATIS.8.1.016004>

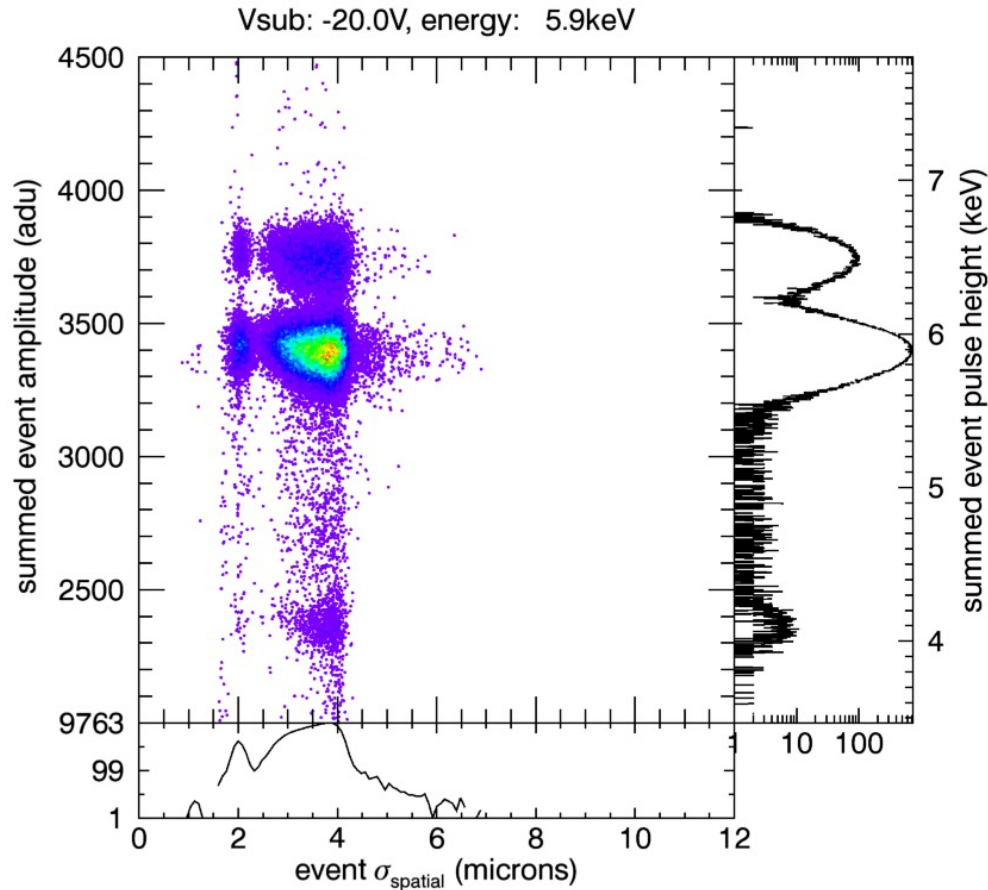
Understanding the effects of charge diffusion in next-generation soft x-ray imagers, Eric D. Miller, Gregory Y. Prigozhin, Beverly J. LaMarr, Marshall W. Bautz, Richard F. Foster, Catherine E. Grant, Craig S. Lage, Christopher Leitz, Andrew Malonis
<https://doi.org/10.1117/12.2628929>

CCID93



- Back illuminated
- 50 micron thick
- 8x8 micron pixels
- Single polysilicon allows fast transfer with 3V clock swings
- 2MHz serial, 500kHz parallel transfer
- $\sim 4.5 e^-$ noise using Archon controller

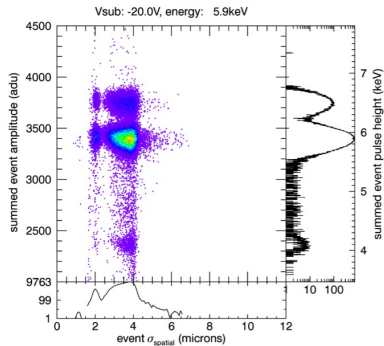
Measurements



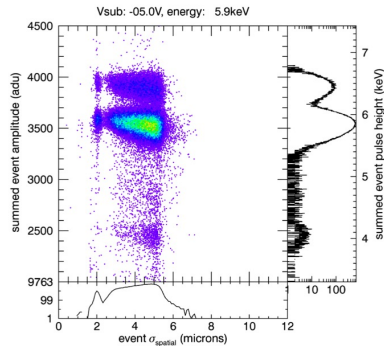
For each event

- compute pulse height with traditional summing above threshold
- Fit a 2-d gaussian to the pulse heights in the island

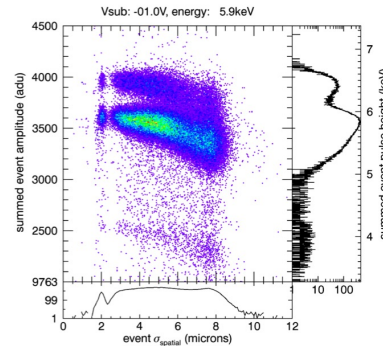
Measurements



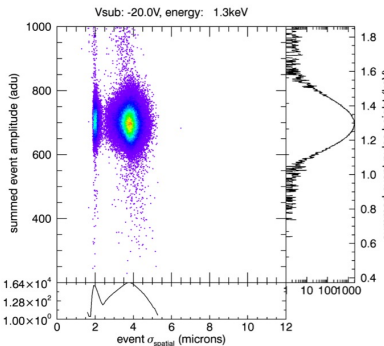
(a) 5.9 keV, $V_{\text{sub}} = -20$ V



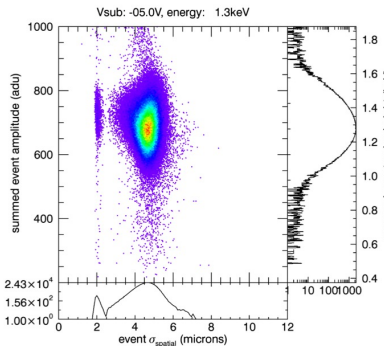
(b) 5.9 keV, $V_{\text{sub}} = -5$ V



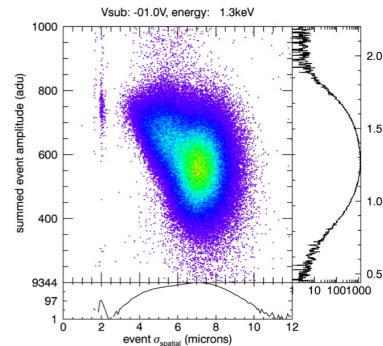
(c) 5.9 keV, $V_{\text{sub}} = -1$ V



(d) 1.25 keV, $V_{\text{sub}} = -20$ V



(e) 1.25 keV, $V_{\text{sub}} = -5$ V

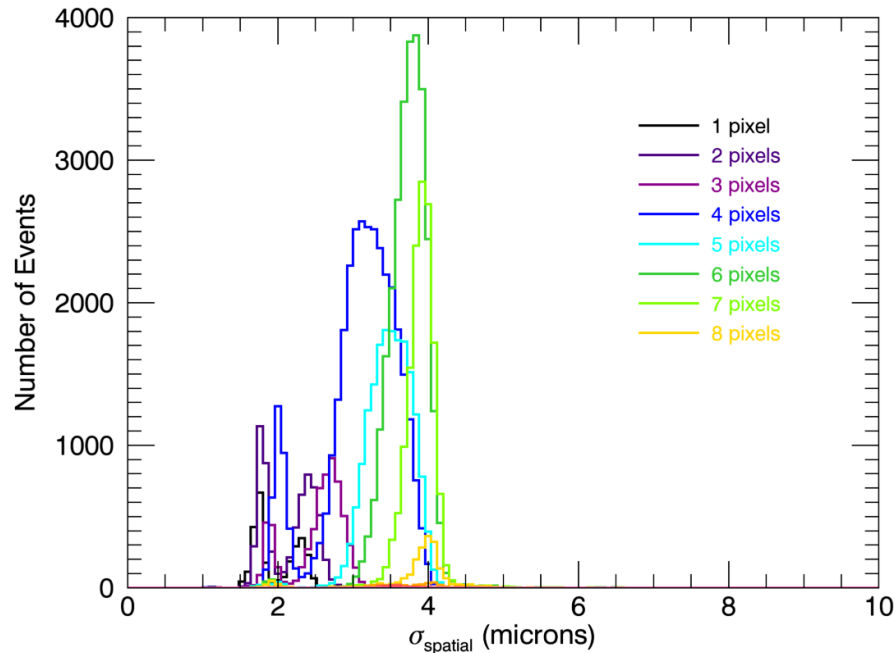


(f) 1.25 keV, $V_{\text{sub}} = -1$ V

- Vary field strength by changing substrate voltage
- Stronger fields result in more rapid charge collection and so less spreading
- Lower bias values do not fully deplete the detector
- Events detected in undepleted region suffer from incomplete charge collection and higher lateral diffusion

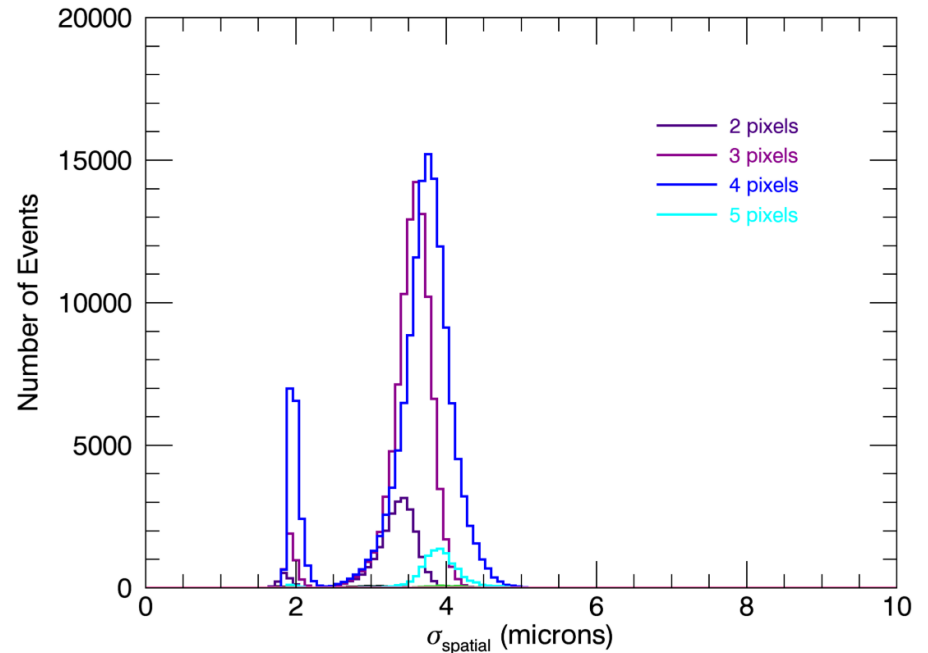
Measurements

Vsub -20V, energy: 5.9keV



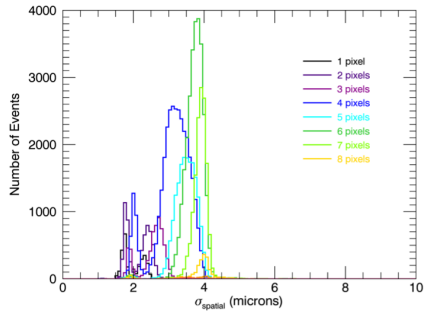
- At 5.9 keV narrower events clearly have fewer pixels above threshold

Vsub -20V, energy: 1.3keV

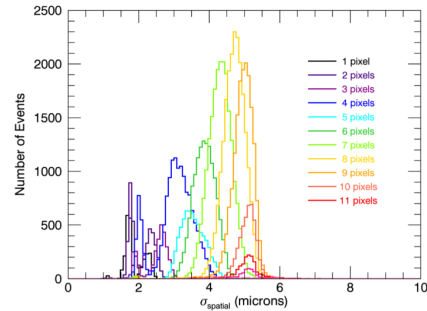


- At 1.3 keV all interactions are closer to the entrance window with less variation in event size.

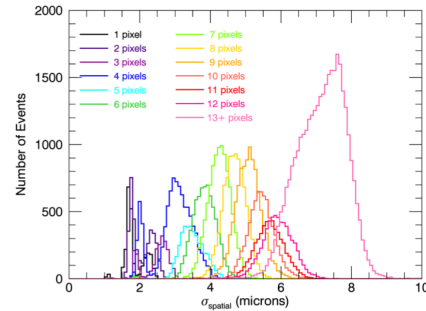
Measurements



(a) 5.9 keV, $V_{\text{sub}} = -20$ V

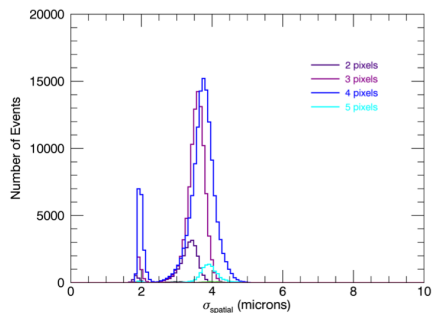


(b) 5.9 keV, $V_{\text{sub}} = -5$ V

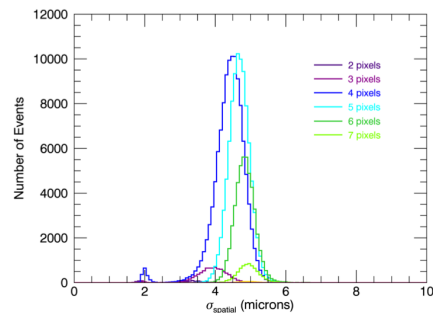


(c) 5.9 keV, $V_{\text{sub}} = -1$ V

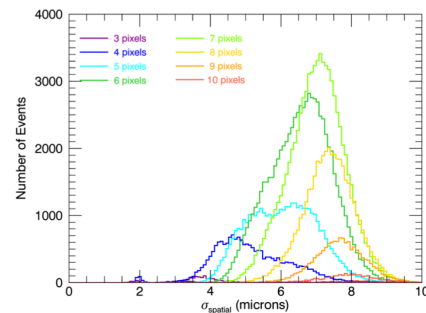
- for a fully depleted detector, the maximum amount of diffusion is the same for both energies



(d) 1.25 keV, $V_{\text{sub}} = -20$ V

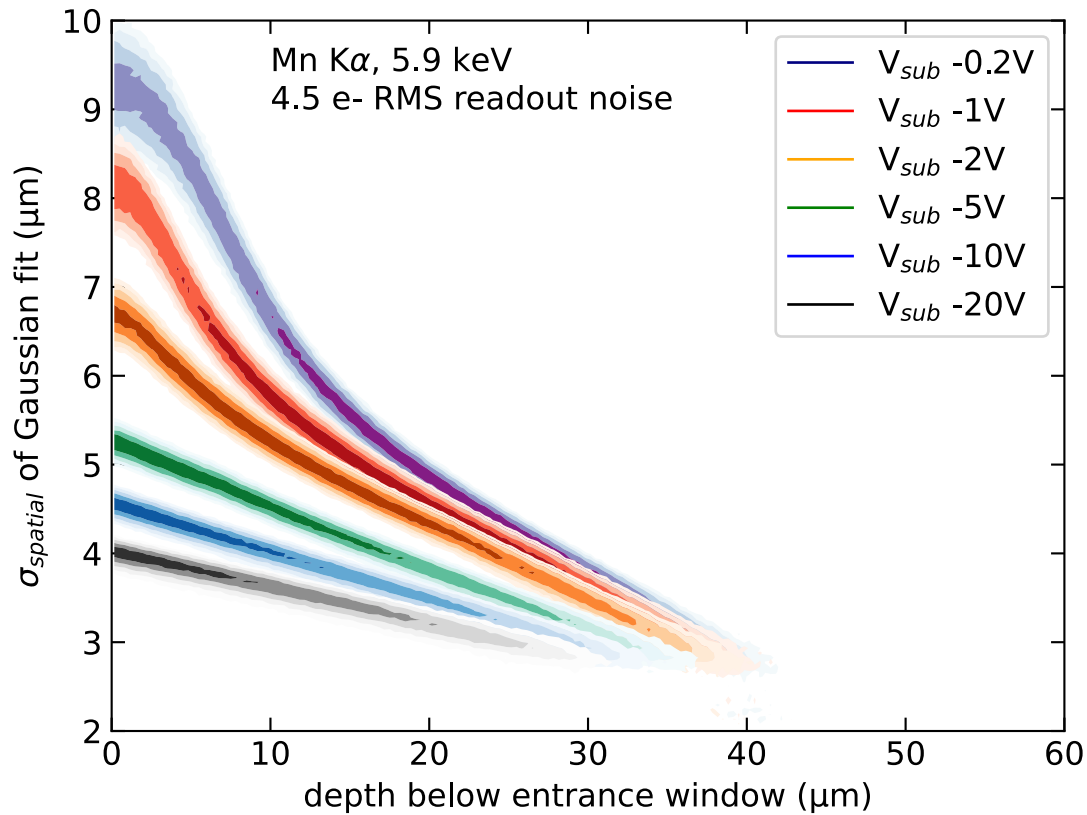


(e) 1.25 keV, $V_{\text{sub}} = -5$ V



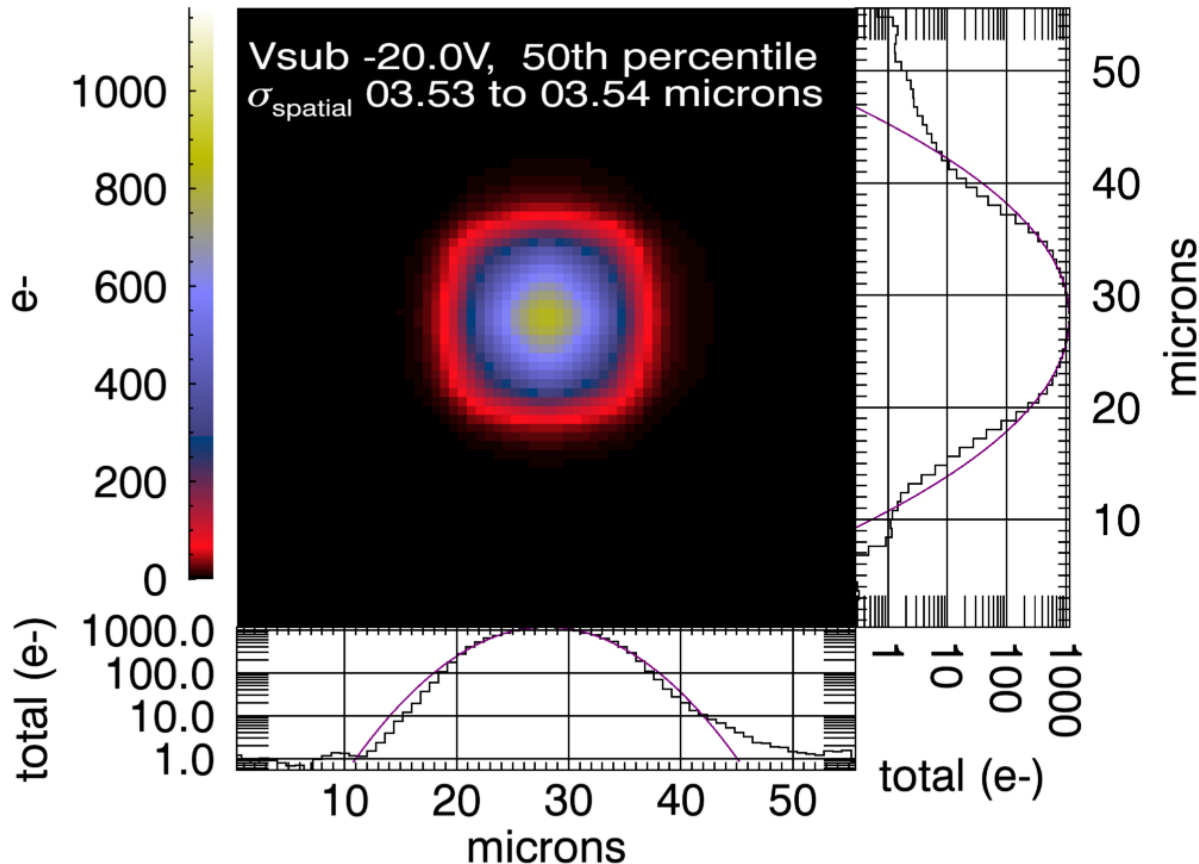
(f) 1.25 keV, $V_{\text{sub}} = -1$ V

Simulation of Average charge distribution at fixed depth



- Simulations provide the expected relationship between the the width of events and the depth of xray absorption
- We use the fact that it is monotonic for a give V_{sub} to sort the events by interaction depth

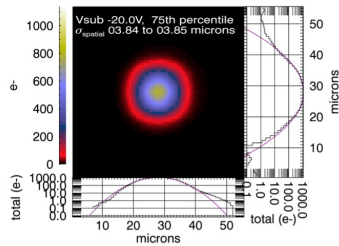
Average charge distribution at fixed depth



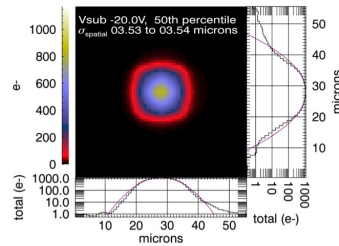
- Rebin each event into a subpixel grid
- Shift each event to align the centroids of the gaussian fits
- Average events with similar widths (and so interaction depths)
- Central portions are well fit by a gaussian

Average charge distribution at fixed depth

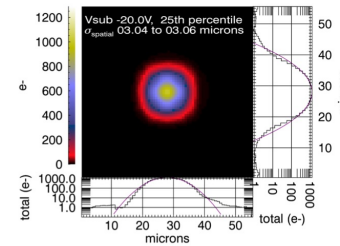
Field strength



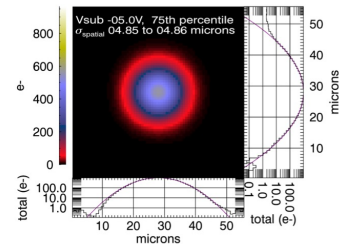
(a) $\sigma_{\text{spatial}} = 3.8 \mu\text{m}$



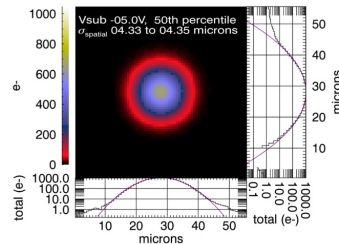
(b) $\sigma_{\text{spatial}} = 3.5 \mu\text{m}$



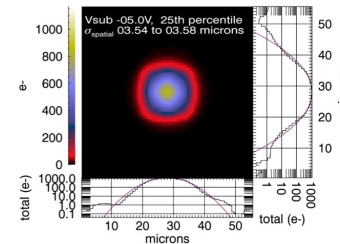
(c) $\sigma_{\text{spatial}} = 3.0 \mu\text{m}$



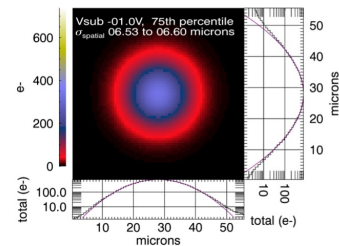
(d) $\sigma_{\text{spatial}} = 4.9 \mu\text{m}$



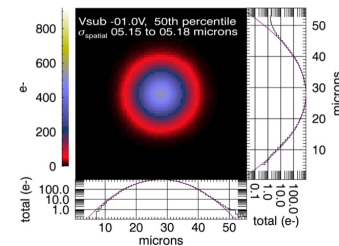
(e) $\sigma_{\text{spatial}} = 4.3 \mu\text{m}$



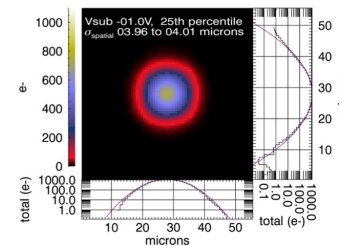
(f) $\sigma_{\text{spatial}} = 3.5 \mu\text{m}$



(g) $\sigma_{\text{spatial}} = 6.5 \mu\text{m}$



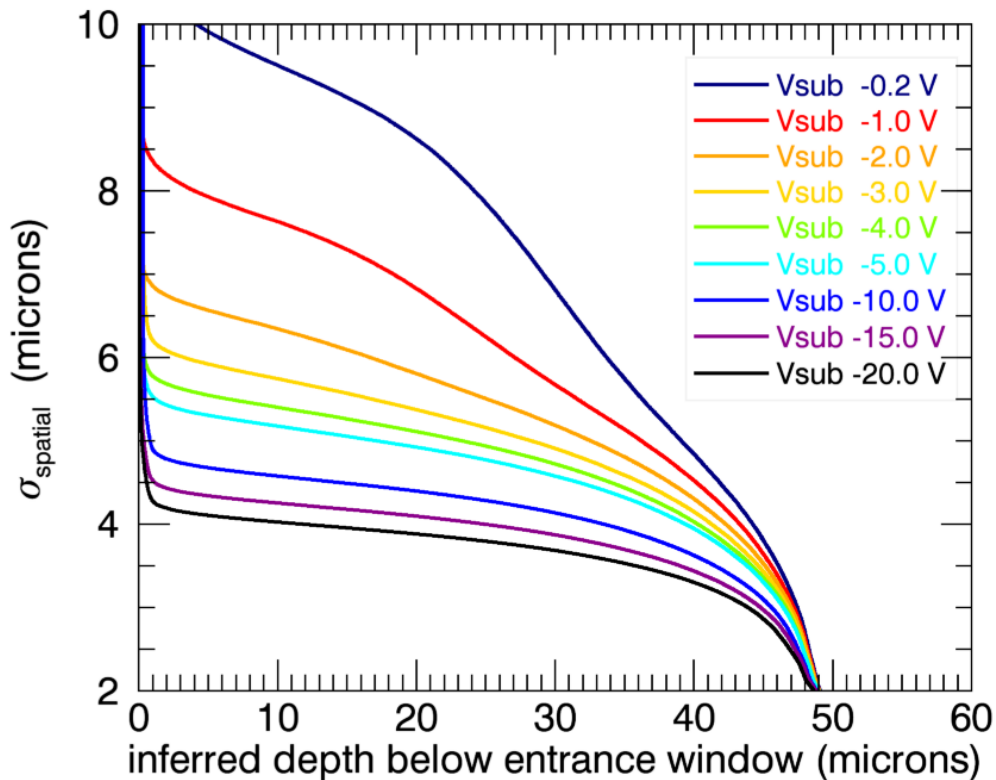
(h) $\sigma_{\text{spatial}} = 5.2 \mu\text{m}$



(i) $\sigma_{\text{spatial}} = 4.0 \mu\text{m}$

Distance from Entrance window

Inferring interaction depth from the cumulative event width distribution

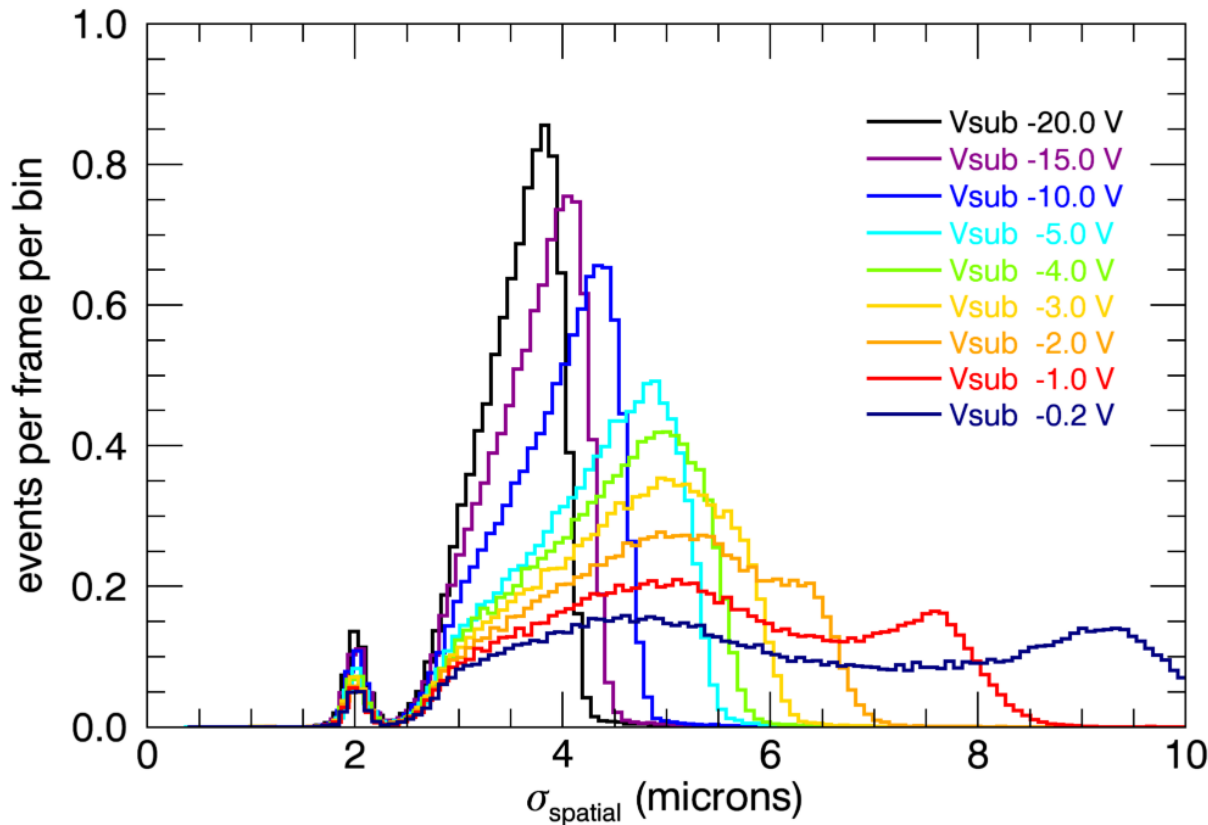


- The shape of the curve is different at less negative V_{sub} s, likely due to the formation of an undepleted region

$$z = -\lambda \ln(1 - N_{z\text{-frac}}(1 - \exp(-t/z)))$$



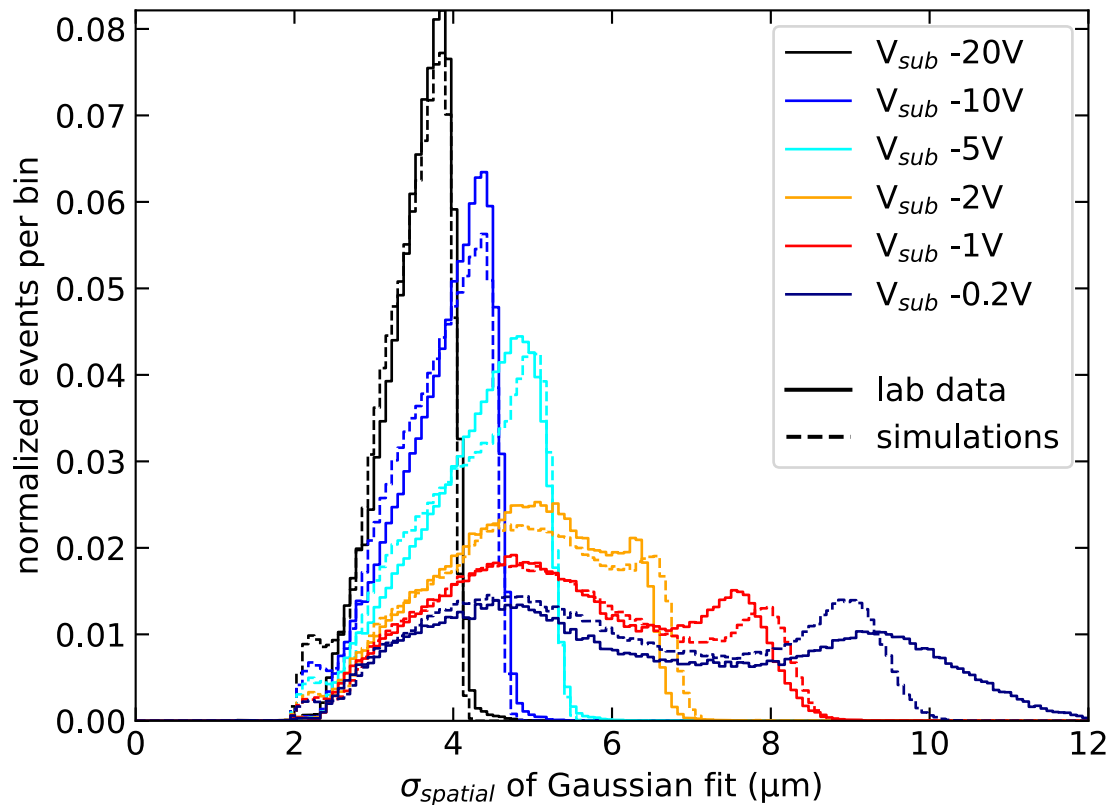
Detector characterization from differential event width distributions



- At the largest bias, the bulk of the silicon is fully depleted and drift times are short
- A second peak forms as an undepleted region forms



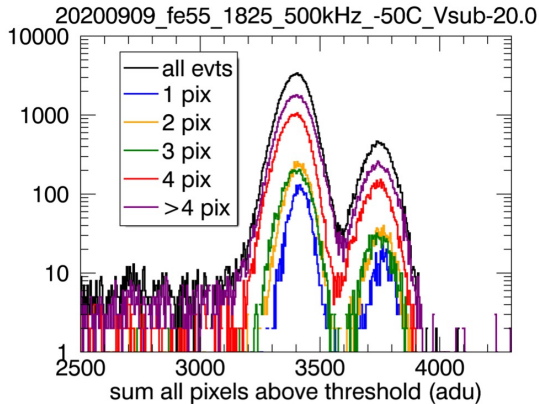
Detector characterization from differential event width distributions



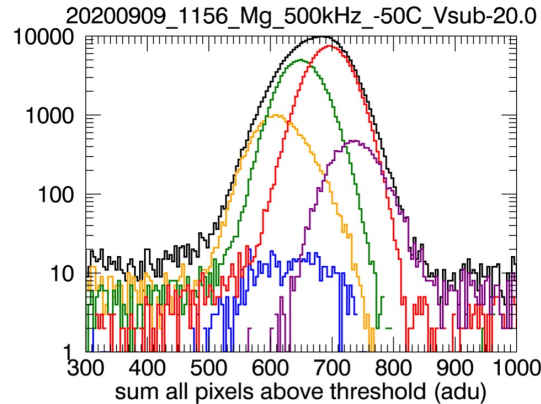
- Tune the POISSON CCD simulator to match the peak location
- Discrepancies at less negative V_{subs} are likely due to limitations in the simulator when a field free region is present.



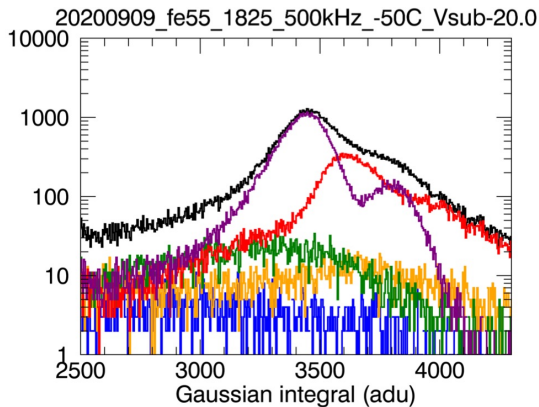
Event Amplitude Estimation



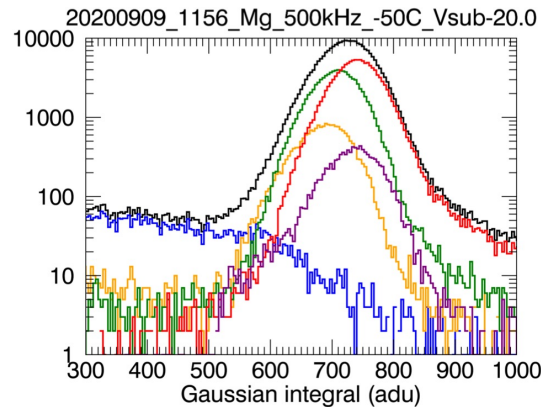
(a)



(b)



(c)

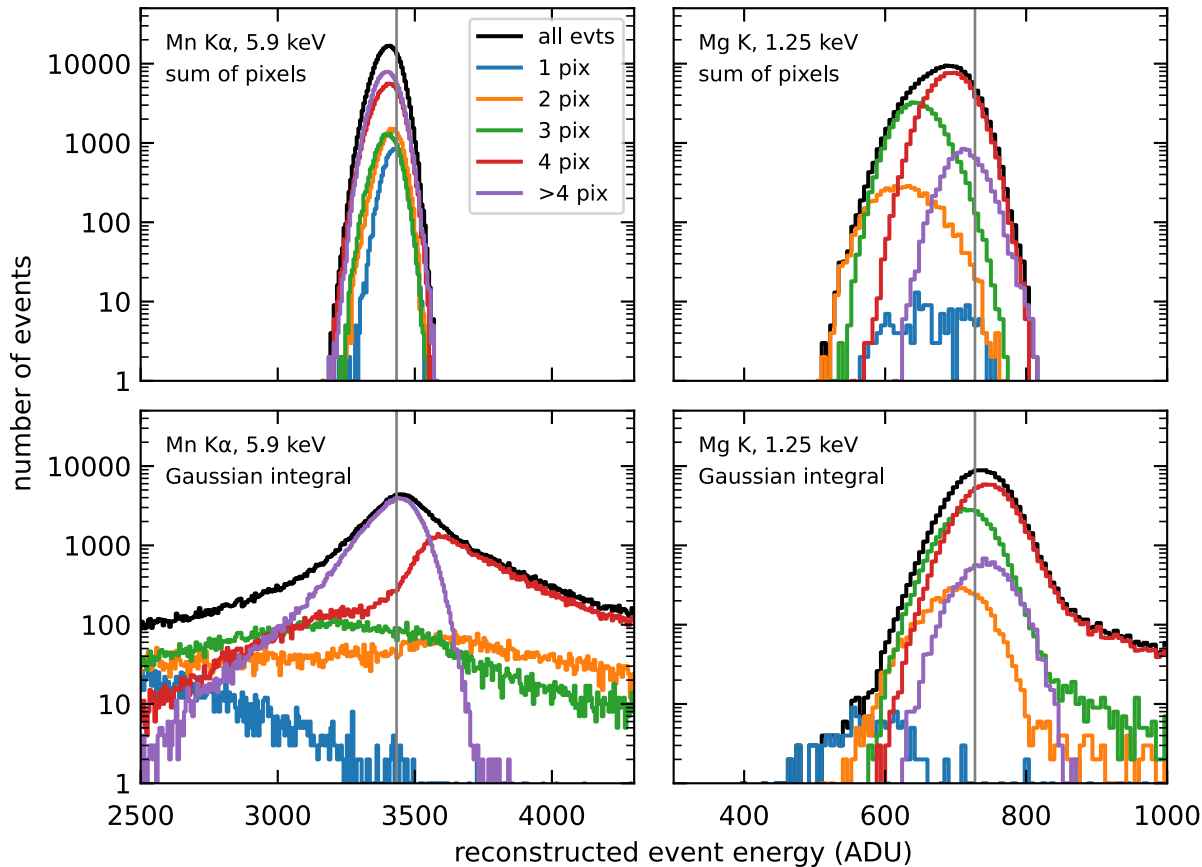


(d)

- Using the gaussian fit for event amplitude estimation performs worse at higher energy. Especially when few pixels are above threshold
- For lower energies, the gaussian amplitudes perform better. Likely due to more extended events



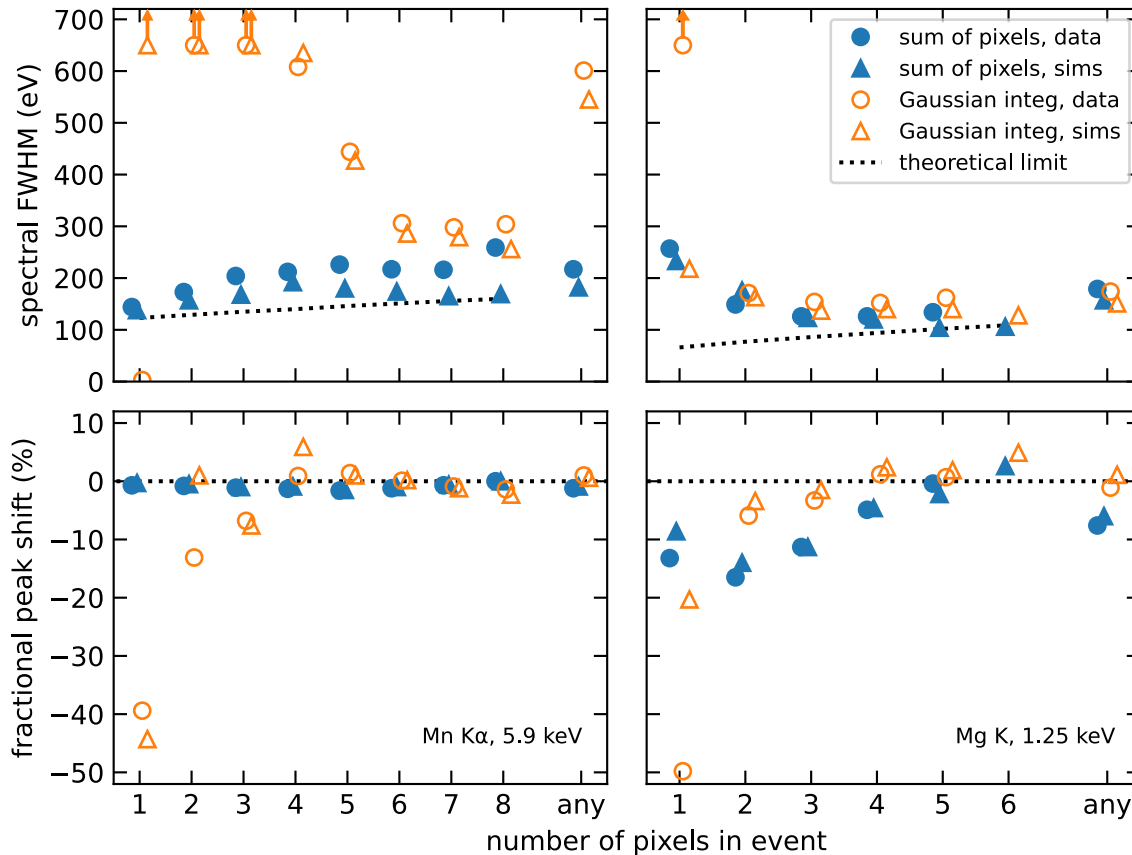
Event Amplitude Estimation



- Results from simulations are similar to the measured data.
- Gaussian fitting method improves the amplitude estimate
- Spatial sampling provided by 8 micron pixels is insufficient for individual events.



Event Amplitude Estimation



- Using the gaussian fit for event amplitude estimation performs worse at higher energy. Especially when few pixels are above threshold
- For lower energies, the gaussian amplitudes perform better. Likely due to more extended events

Summary

- Thick, small pixel, back illuminated devices have significant charge spreading
- Fitting 2d gaussians to the event items allow an estimation
- The POISSON CCD simulator is able to match the spread well
- Traditional charge above split event amplitude calculation is still best for energies above 1keV